

Title (en)  
COATING ARRANGEMENT

Title (de)  
BESCHICHTUNGSANORDNUNG

Title (fr)  
AGENCEMENT DE REVÊTEMENT

Publication  
**EP 4274917 A1 20231115 (DE)**

Application  
**EP 21786209 A 20210930**

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Abstract (en)  
[origin: WO2022148560A1] The invention relates to a coating arrangement (2) for depositing a coating material on a substrate (3). The coating arrangement has a coating chamber (4') with a coating channel (4), and a coating apparatus having: an evaporation portion (11, 23, 7, 12, 13) with a crucible (13) for bringing the coating material into a gaseous phase; a nozzle portion (14) which is located on the outside of the evaporation portion, is preferably coupled thereto, and comprises a nozzle output (15); and a particle supply device (20) with a supply opening (21) for supplying particles into the evaporation portion (11, 23, 7, 12, 13). Suction lines (17, 18) and a filter device (19) can also be provided.

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